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Ву:

Date: September 17, 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No.

10/715,073

Confirmation No.: 3310 ·

Applicant

Torsten Seidel et al.

Filed Title November 17, 2003

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CONFIGURATION AND METHOD FOR DETECTING DEFECTS ON

A SUBSTRATE IN A PROCESSING TOOL

Art Unit

2624

Examiner Docket No.

Samir A. Ahmed P2001,0356

Customer No.

24131

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR § 1.97

Hon. Commissioner for Patents Alexandria, VA 22313-1450

Sir:

In accordance with 37 CFR § 1.98 copies of the following patents and/or publications are cited herewith:

English Translation of Korea patent office Unexamined Patent Publication KR 2001-0035816 (Lee et al.), dated May 07, 2001.

In accordance with 37 CFR § 1.97(e) the undersigned herewith states that each item of information contained in the information disclosure statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of the information disclosure statement.

Respectfully submitted

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